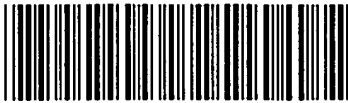


Search Notes

Application/Control No.

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Examiner

Kimberly D. Nguyen

Applicant(s)/Patent under
Reexamination

NAKABE, FUTOSHI

Art Unit

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SEARCHED

Class	Subclass	Date	Examiner
235	487 492 435 376 451	3/26/2006	KN
708	250 255	8/18/2006	KN

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
SAME AS	ABOVE	8/18/2006	KN

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Patents 6,749,117; 6,923,380; 7,011,250; 7,011,252; 7,016,924 reviewed for possible Double Patenting rejection.	3/26/2006	KN
Keyword search attached	3/26/2006	KN